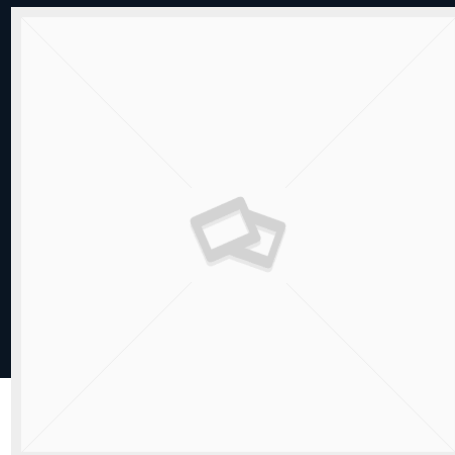


RADICAL PLASMA SOURCE (REMOTE PLASMA SOURCE) - MA2000C-913BB

Category: [Plasma components](#)



ADDITIONAL INFORMATION

Typ	<u>Radical plasma source (Remote Plasma Source)</u>
Process	<u>Etching & Deposition</u>
Output Connection Type	<u>ISO-K 63</u>
Dielectric material	<u>Sapphire</u>
Mains voltage nominal [V]	<u>230 / 208</u>
Output Power [W]	<u>2000</u>
Frequency [Mhz]	<u>2450</u>